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9-11-02

FORM PTO-1449 (REV. 6-89)	U.S. DEPARTMENT OF COMMERCE Patent and Trademark Office	Attorney's Docket No. 22120-06499	Serial No. 10/029,521
INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)		Applicant Christopher F. Bevis	
		Filing Date December 21, 2001	Group Art Unit 2825

U.S. PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate

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FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation Yes	Translation No

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

TD	A	SPIE Handbook of Microlithography, Micromachining and Microfabrication, Vol. 1: Microlithography [online], [retrieved on 2001-11-29] Retreived from <URL: http://www.cnf.cornell.edu/SPIEBook/spie9.htm
TD	B	Operations Manual for Model F5, KLA-Tencor Corp., Chapters 3, 4: Creating and Editing Recipes, Manual: 04-0452A, Dec. 1998, pp. 3-1 to 4-44
TD	C	Operations Manual for Model AIT, KLA-Tencor Corp., Chapters 4,5: Creating Recipes, #530131-36 Rev. A 4/99, pp. 77-144

EXAMINER Umemoto DATE CONSIDERED 4-1-03

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